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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/602,395
Filing Date June 22, 2000
Inventor John T. Moore
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Pham, T.
Attorney's Docket No. MI22-1384
Title: Methods of Forming Oxide Regions Over Semiconductor Substrates

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: 3-15-2002

By: Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
Reg. No. 48,711

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